Docket Number: 081468-0307015 PATENT APPLICATION

Client Reference: P-1749.000-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

PETER TEN BERGE, et al.

Group Art Unit:

Application No.:

Examiner:

Filed: December 1, 2003

Confirmation No.:

For: SUBSTRATE, METHOD OF PREPARING A SUBSTRATE, METHOD OF MEASUREMENT, LITHOGRAPHIC APPARATUS, DEVICE MANUFACTURING METHOD AND DEVICE MANUFACTURED THEREBY, AND MACHINE-READABLE STORAGE MEDIUM

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date of this non-CPA application. No certification or fee is required.

Respectfully Submitted,

Kerry T. Hartman

Registration Number 41818

Date: December 1, 2003 PILLSBURY WINTHROP LLP Telephone: (703) 905-2000 Facsimile: (703) 905-2500

P.O. Box 10500 McLean, VA 22102 Docket Number: 081468-0307015 PATENT APPLICATION

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